Form PTO-1556 TRANSFORME	D3-13-2003
(Rev. 10/02)	U.S. Patent and Trademark Offic
To the Honorable Commissioner of Patents and Tradem 1. Name of conveying party(ies): NAKAHARA, Hijiri TAKEUCHI, Yukihiko HASHIMOTO, Ryou MARUYAMA, Taketo ABE, Hisaki	 harks: Please record the attached original documents or copy thereof. 2. Name and address of receiving party(ies) Name (1) SHARP KABUSHIKI KAISHA Street Address: 22-22. Nagaike-cho, Abeno-ku, Osaka-shi, Osaka, Japan
Additional name(s) of conveying party(ies) attached? Yes 3. Nature of conveyance:	No Name: (2) MITSUBISHI GAS CHEMICAL COMPANY
Assignment Grange of Name Other	Street Address: 5-2. Marunouchi, 2-chome, Chiyoda-ku, Tokyo, Japan
Execution Date: Eebruary 3, 2003	Additional name(s) & address(es) attached? Yes X No
 Application number(s) or patent number(s): If this document is being filed together with a new application A. Patent Application No.(s) 	tion, the execution date of the application is: B. Patent Registration No.(s)
10/315,073 Filed December 10, 2002	
Additional numb	
 Name and address of party to whom correspondence concerning document should be mailed: 	6. Total number of applications and patents involved
Name: Antonelli, Terry, Stout & Kraus, LLP	7. Total fee (37 CFR 3.41)\$ ⊠ Enclosed
Internal Address:	Authorized to be charged to deposit account
1300 North Seventeenth Street Suite 1800 Arlington, VA 22209	8. Deposit account number:
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PATENT REEL: 013827 FRAME: 0799

ASSIGNMENT

For good and valuable consideration, the sufficiency and receipt of which is hereby acknowledged, as a below (1) Sharp Kabushiki Kaisha (2) Mitsubishi Gas Chemical Company. Inc.

named inventor. I hereby sell and assign to(2) introduction day offening a company. The
(1) 22-22, Nagaike-cho, Abeno-ku, Osaka-shi, Osaka, Japan
of (2) 5-2, Marunouchi 2-chome, Chiyoda-ku. Tokyo, Japan

its successors and assigns or other legal representatives all my rights, title and interest, in and for the United States of America, in and to

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invented by me (if only one is named below) or us (if plural inventors are named below) and described in the application for United States Letters Patent therefor, executed by me even date herewith, and all United States Letters Patent which may be granted therefor, and all divisions, continuations and extensions thereof, the said interest being the

(1) Sharp Kabushiki Kaisha (2) Mitsubishi Gas Chemical Company. Inc., its successors, assigns or other legal representatives, to the full end of the term for which said Letters Patent may be granted, as fully and entirely as the same would have been held and enjoyed by me or us if this assignment and sale had not been made;

And I hereby agree to sign and execute any further documents or instruments which may be necessary, lawful, and proper in the prosecution of the above-named application or in the preparation and prosecution of any continuing, continuation-in-part, substitute, divisional, renewal, reviewed or reissue applications or in any amendment, extension, or interference proceedings, or otherwise to secure the title thereto in said assignee;

				ull Name)	(Signature)
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	ness(es)				
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RECORDED: 03/06/2003